

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Re Application of

Chen T. GABRIEL, et al.

Serial No.: 09/887,165

Filed: June 25, 2001

Customer Number: 20277

Confirmation Number: 7774

Group Art Unit: 1763

Examiner: George A. Goudreau

For: N-CONTAINING PLASMA ETCH PROCESS WITH REDUCED RESIST POISONING

Mail Stop No Fee - Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.
- ☒ Applicant is entitled to small entity status under 37 CFR 1.27
- ☒ Also attached: Petition For Reconsideration of Holding of Abandonment with copies of January 3, 2003 Page of Secretary Docket Book and January 3, 2003 Firm Master Docket

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	10	20	0	\$18.00 =	\$0.00
Independent Claims	2	3	0	\$86.00 =	\$0.00
Multiple claims newly presented					\$0.00
Fee for extension of time					\$0.00
Total of Above Calculations					\$0.00

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

MCDERMOTT, WILL &amp; EMERY

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